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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/787,405	02/27/2004	Heon-Do Yun	041993-5364	4520	
	7590 02/01/2007 ONG & ALDRIDGE LLP		EXAM	INER	
1900 K STREE	ET, NW		EXAMINER CHIEN, LUCY P ART UNIT PAPER NUMBER 2871	LUCY P	
WASHINGTO	N, DC 20006		ART UNIT PAPER NUMBER		
			2871		
SHORTENED STATUTOR	Y PERIOD OF RESPONSE	MAIL DATE	DELIVERY MODE		
3 MO	NTHS	02/01/2007	PAPER		

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

	Application No.	Applicant(s)	
	10/787,405	YUN ET AL.	
Office Action Summary	Examiner	Art Unit	
	Lucy P. Chien	2871	
The MAILING DATE of this communication a			
Period for Reply			
A SHORTENED STATUTORY PERIOD FOR REF WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory periodal Failure to reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the mail earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUN 1.136(a). In no event, however, may be will apply and will expire SIX (6) Mu tute, cause the application to become	IICATION. a reply be timely filed DNTHS from the mailing date of this communicat ABANDONED (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on			
	nis action is non-final.		
3) Since this application is in condition for allow	vance except for formal ma	atters, prosecution as to the merits	is
closed in accordance with the practice under	r <i>Ex par</i> te Q <i>uayle</i> , 1935 C	.D. 11, 453 O.G. 213.	
Disposition of Claims			
4)⊠ Claim(s) 2,3 and 8-21 is/are pending in the a	application.		
4a) Of the above claim(s) <u>8-16</u> is/are withdra		·	
5) Claim(s) 3 is/are allowed.			
6) Claim(s) 2 and 17-21 is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and	I/or election requirement.		
Application Papers			
9) The specification is objected to by the Exami	ner.		
10)⊠ The drawing(s) filed on <u>27 February 2004</u> is/s	are: a)⊠ accepted or b)[objected to by the Examiner.	
Applicant may not request that any objection to the	ne drawing(s) be held in abey	ance. See 37 CFR 1.85(a).	
Replacement drawing sheet(s) including the corre	•		
11) The oath or declaration is objected to by the	Examiner. Note the attach	ed Office Action or form PTO-152.	,
Priority under 35 U.S.C. § 119			
12)⊠ Acknowledgment is made of a claim for foreign	gn priority under 35 U.S.C	. § 119(a)-(d) or (f).	
 a) All b) Some * c) None of: 1. Certified copies of the priority docume 	ents have been received		
2. ☐ Certified copies of the priority docume		Application No	
3. Copies of the certified copies of the pr			
application from the International Bure	•		
* See the attached detailed Office action for a li	st of the certified copies n	ot received.	
Attachment(s)			
1) Notice of References Cited (PTO-892)		v Summary (PTO-413)	
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0 Paper No(s)/Mail Date 		o(s)/Mail Date f Informal Patent Application (PTO-152)	

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DETAILED ACTION

Response to Arguments

Applicant's arguments with respect to claim 2,18,20,21 have been considered but are most in view of the new ground(s) of rejection.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 2,17-21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akahira (US 6471352) and of Ueno (JP 09-166783) in view of Ben-Zur (US 20050179708).

Akahira discloses (figure 27C) providing a substrate having a plurality of unit panels formed thereon, loading the substrate onto a stage (Fig. 1, 52) and forming an alignment layer on the substrate to have a uniform thickness selectively dropping ink onto a first one of the unit panel regions by a dropping unit (Figure 1, items 55 and Figure 3, nozzles 108), having a plurality at least one head each head having a plurality of holes (Figure 27D). Wherein the selective dropping of the alignment material onto the substrate.

Akahira does not disclose dropping alignment material. Nor does Akahira disclose the specific movement of the alignment material dropping unit.

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Examiner is using Ueno as a reference to disclose that using the dropping unit panels can be used for dropping alignment material. (Abstract)

Examiner is using Ben-Zur to disclose the specific movement of the droping unit. Ben-Zur discloses positioning dropping unit at a first side of the stage ([0047]) driving the alignment material dropping unit from the first side to a second side (x axis) of the stage to drop the alignment material through holes along a plurality of first dropping paths along a first dropping directions shifting (y axis) the alignment material dropping unit by a predetermined distance along a direction substantially perpendicular to the first dropping direction driving the alignment material dropping unit from the second side to the first side of the stage to drop the alignment material through holes along a plurality of second dropping paths wherein the second dropping paths are disposed between first dropping paths.

It would have been obvious to one of ordinary skilled in the art to modify

Akahira's method of forming color film using a plurality of unit panels to include Ueno's method of forming an alignment film that uses a plurality of unit panels to prevent a decrease in the display performance by providing a uniform orienting film (Abstract).

Also, to include Ben-Zur et al's dropping unit movement motivated by the desire to provide a more efficient way of dropping material on a substrate [0005].

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Allowable Subject Matter

Claim 3 is allowed.

The following is a statement of reasons for the indication of allowable subject matter: The shift distance of the alignment material dropping unit is smaller than a distance between the holes.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lucy P. Chien whose telephone number is 571-272-8579. The examiner can normally be reached on M-F 8:30-5:00.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571)272-1787. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Lucy P Chien Examiner Art Unit 2871

A LU SULLANDREW SCHECHTER

REIMARY EXAMINES